

Motivation



- Contribute to ALICE ITS upgrade project, targeting at heavy flavor physics
- Learn high precision and automatic assembly technique and transfer it to PLAC/HFEE applications

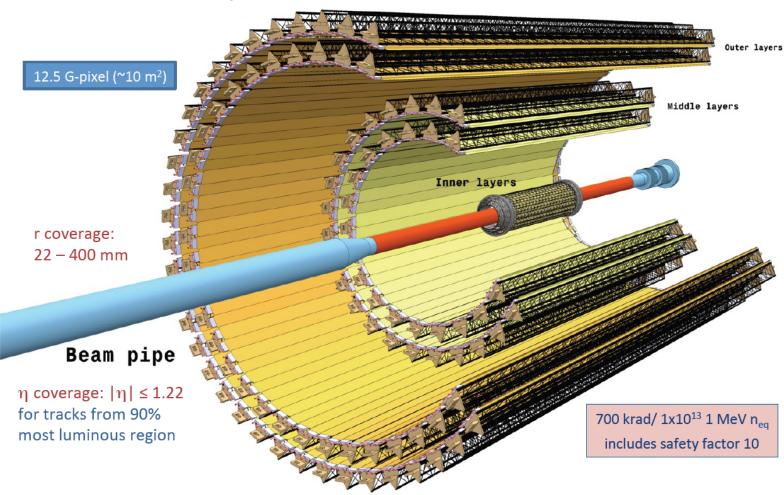
Following contents are mostly from V. Manzari (Bari/INFN) and A. Di Mauro (CERN)'s talks at "4th ALICE ITS upgrade, MFT and O² Asian Workshop 2014@Pusan"



Detector Layout Overview



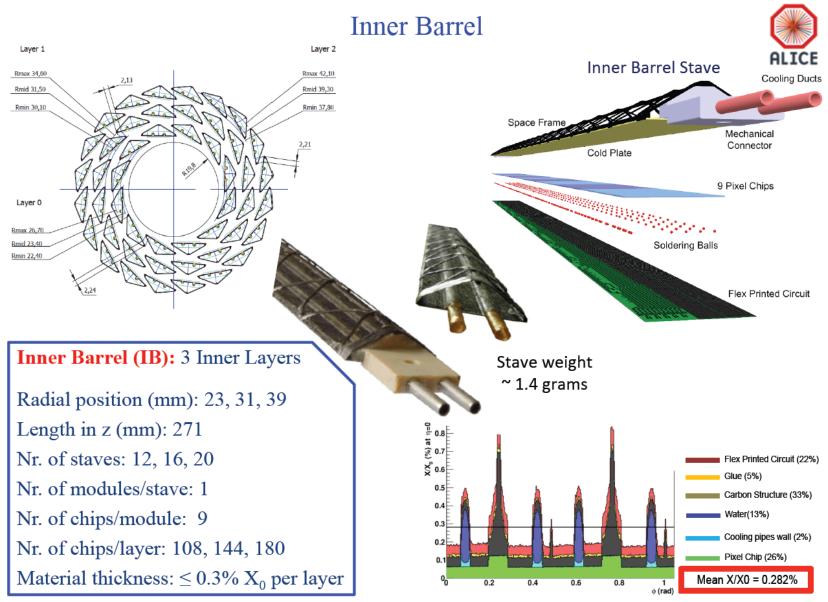
7 layers of Monolithic Active Pixel Sensors



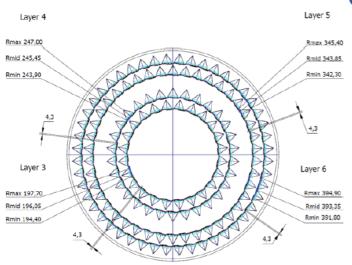
V. Manzari - ALICE ITS upgrade, MFT and O² Asian Workshop 2014 @ Pusan -15 Dec '14

2



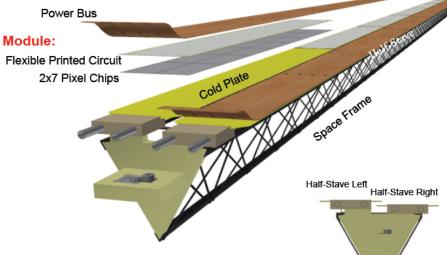






Outer Barrel





Outer Barrel (OB): 2 ML + 2 OL

Radial position (mm): 196, 245, 344, 393

Length in z (mm): 843, 1475

Nr. of staves: 24, 30, 42, 48

Nr. of half-staves/stave: 2

Nr. of modules/half-stave: 4 (ML), 7 (OL)

Nr. of chips/module: 14

Nr. of chips/layer: 2688, 3360, 8232, 9408

Material thickness: $\sim 1\% X_0$ per layer

Module to Module and Power Bus connections





No. of modules and interconnections:

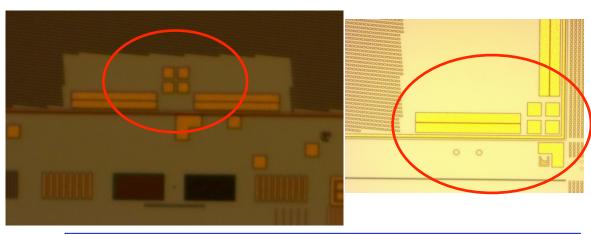
- Some redundancy in the quantity of modules to be produced is required, specifically 120% for the IB, 20% for the OB, resulting in a total 2136 Hybrid Integrated Circuits (HICs); more specifically:
 - IB: n. 106 "9-chips" HICs (954 chips to be soldered)
 - OB: n. 2030 "14-chips" HICs (28420 chips to be soldered)
- Considering ~ 80 pads/chip → ~ 2.4 M interconnections

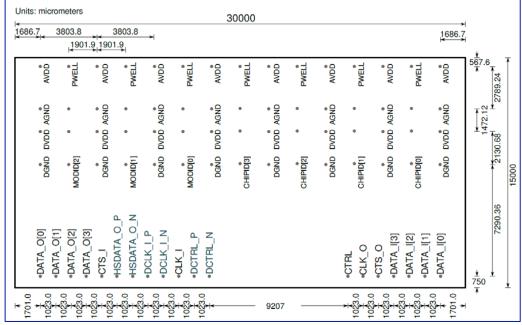


Silicon chip main characteristics:

- 30x15 mm silicon chip, thinned to 50± 5 μm; dicing tolerance -0/+30 μm
- Contact pads are in aluminium, coated by Ni/Au, 300 μm diameter
- Reference targets at the four corners and along the edges
- Chips warp ~ 0.5 mm







18/12/2014 7



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FPC main characteristics:

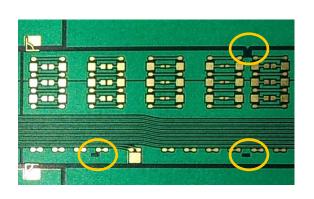
3 layouts:

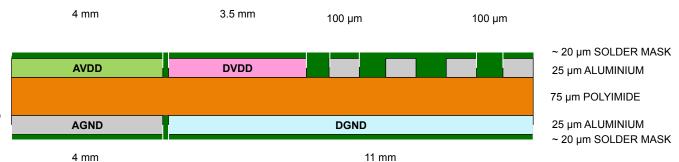
IB: 1x9 chips, Al

OB: 2x7 chips, Cu

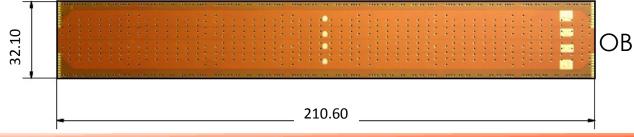
MFT: 1x1, 1x2,..., 1x5chips , Al

- Metallised vias of 220 μm diameter
- Two openings of 1x1 and 1x0.4 mm², respectively, to "see" chip targets



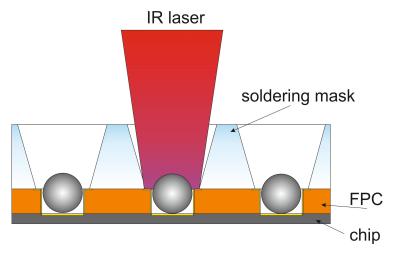








Laser soldering main characteristics:



- Interconnection between FPC and chip by fluxless laser soldering of 200 μm diameter Sn/Ag(96.5/3.5) balls (227 °C melting T) in vacuum (≤10-1 mbar)
- IR diode laser, 976 nm, 25 W, 50 mm focal length,
 0.25 mm beam spot size
- Laser power modulated by pyrometer (LASCON ® system supplied by Dr. Mergenthaler GMBH & CO), programmable T profile ensures precise limitation of heating
- Soldering mask (in Macor® or Rubalit ®) used to push
 FPC on chip and guide soldering balls inside FPC vias

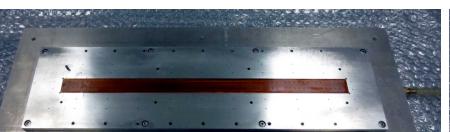






Tooling for the module assembly: IB work table

The chips vacuum chuck



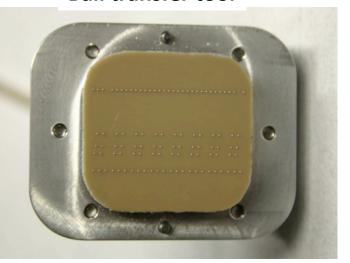
Vacuum lid with quartz window



The soldering mask

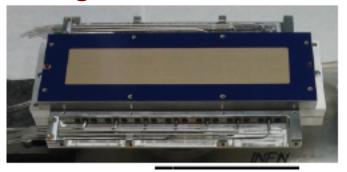


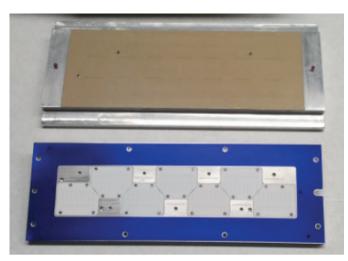
Ball transfer tool

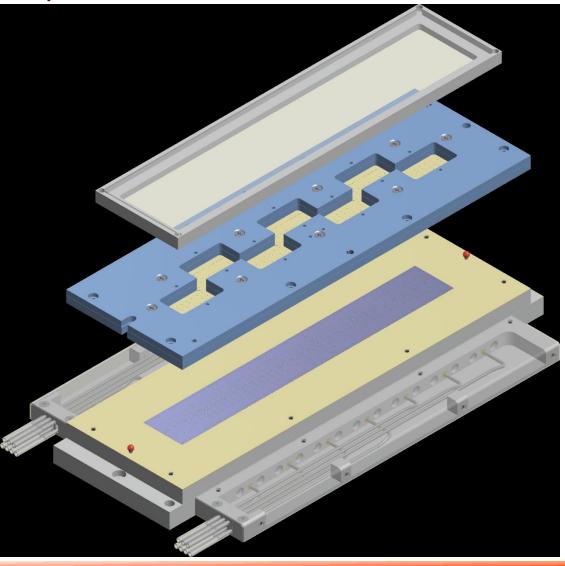




Tooling for the module assembly: OB work table









Accuracy required to the module assembly:

- Presently, final accuracy of FPC hole position not yet known:
 - IB: Al FPC \sim 50 μm (hope to improve it)
 - OB: Cu FPC \sim 20 μ m
- The 300 μ m pad can compensate hole position variations up to ± 40 μ m
- The 100 μ m gap between chips seal ring, with the present dicing accuracy, translates in a physical gap between chip edges of ~ 40-50 μ m (if needed it could be increased)
- A chip placement accuracy of \pm 5 μm is a very tight and conservative requirement to prevent issues related to FPC/chip alignment

Key aspects of the module assembly:

- The amount of modules and the time available require a distributed production over 6 sites (Bari/Italy, CERN, Liverpool/UK, Pusan/Korea, Strasbourg/France, Wuhan/China).
- Usage of same procedure and system is necessary to ensure homogenous production
- To simplify/shorten the assembly procedure, chips are placed in nominal positions and FPC is overlapped using nominal pinholes



Baseline module assembly system:

- Semi-automatic placement of chips on flat vacuum chuck: operator moves chips from pallet using a console, placement assisted by vision system, inter-chip gap (from seal-ring) of 100 μ m, required position tolerance of \pm 5 μ m at 3 σ with respect to reference targets on assembly table
- Stack of FPC + soldering mask placed manually by operator on top of chips
- Distribution of 200 μm soldering balls inside mask holes by operator
- Mounting of lid with quartz window and start of vacuum pump by operator
- Automatic laser soldering of each interconnection; X,Y positioning accuracy: \pm 30 μ m. Three different modes of operations:
 - fully manual by console; this mode is used for testing purposes and laser beam focusing optimization;
 - programmable in X,Y, providing coordinates either as keyboard input or from a file;
 - fully automated, centred in FPC holes recognized by the vision system.

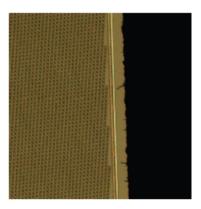
18/12/2014 13

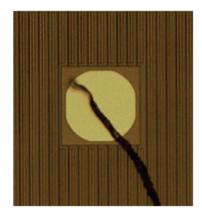


Module assembly procedures:

1. Chip visual inspection – dimensions, warp, integrity, cleanness

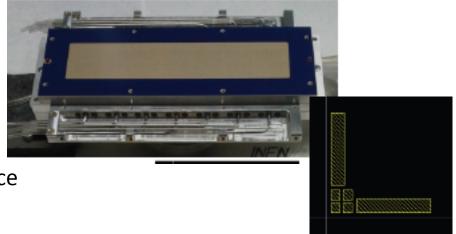






2. Chip placement/alignment – pick up from the chip pallet and place above a vacuum chunk in nominal position w.r.t. reference point

- 9 (14) chips one by one
- Use reference markers on chip surface and vacuum chuck
- Gap beween adjacent chips:





Module assembly procedures:

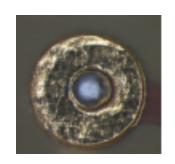
3. FPC placement/alignment – placement above the chips array in nominal position using a jig embedding a soldering mask.

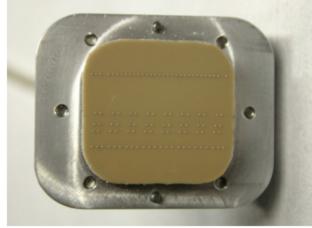
- Use locating pinholes and ruby spheres
- The soldering mask is a ceramic plate with 0.5 mm holes corresponding to the FPC vias
- The jig gently press the FPC against the pixel chips to minimize the gap between them



4. Soldering balls placement – fill the soldering mask holes with the soldering balls using the ball transfer tool

- The soldering mask guides the soldering balls into the FPC vias
- One chip at a time, use pinholes for alignment
- Visual inspection to ensure each hole if filled one and only one soldering ball





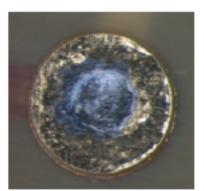


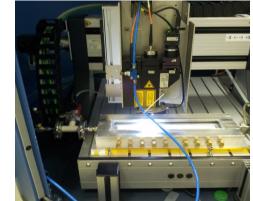
Module assembly procedures:

- **5. Soldering readiness** install the vacuum tight lid equipped with the quartz window above the pixel chips, FPC and soldering mask stack-up
 - Start vacuum pump to empty the soldering volume till ready for laser soldering
 - Pressure of the chip vacuum chuck always smaller than the soldering volume



- **6. Laser soldering** shoot laser through the quartz window onto each soldering balls in sequence to melt them and establish the connection between FPC and chip
 - Visual checks of soldering joints







OB module construction:

 Procurement of the automatic assembly systems is centrally managed by the project with a tendering launched from CFRN.



IT_4029/PH/ALICE

The ALICE ITS Upgrade Project

Invitation to Tender

Technical Specification

Supply of automatic assembly systems for the Hybrid Integrated Circuits of the ALICE ITS and MFT upgrade projects

Abstract

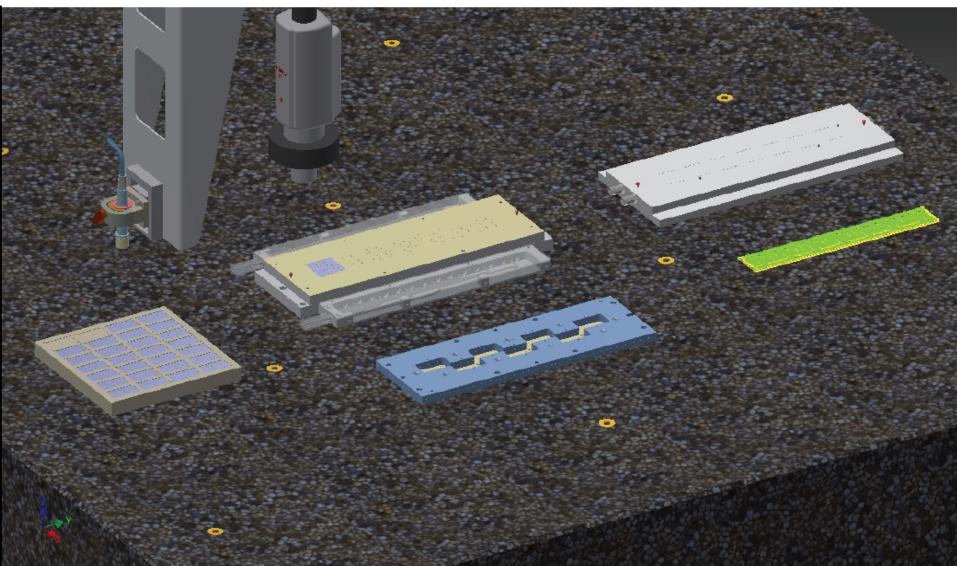
This technical specification concerns the supply of automatic assembly systems for the so-called Hybrid Integrated Circuits of the ALICE ITS and MFT upgrade projects.

The systems shall allow large surface silicon dies pick and placement, with an accuracy of $\pm 5~\mu m$ at 3σ , by an operator using stages controlled by a console and vision system assistance. In addition, interconnection of silicon dies and flexible printed circuit shall be performed automatically by laser soldering of $200~\mu m$ soldering balls.

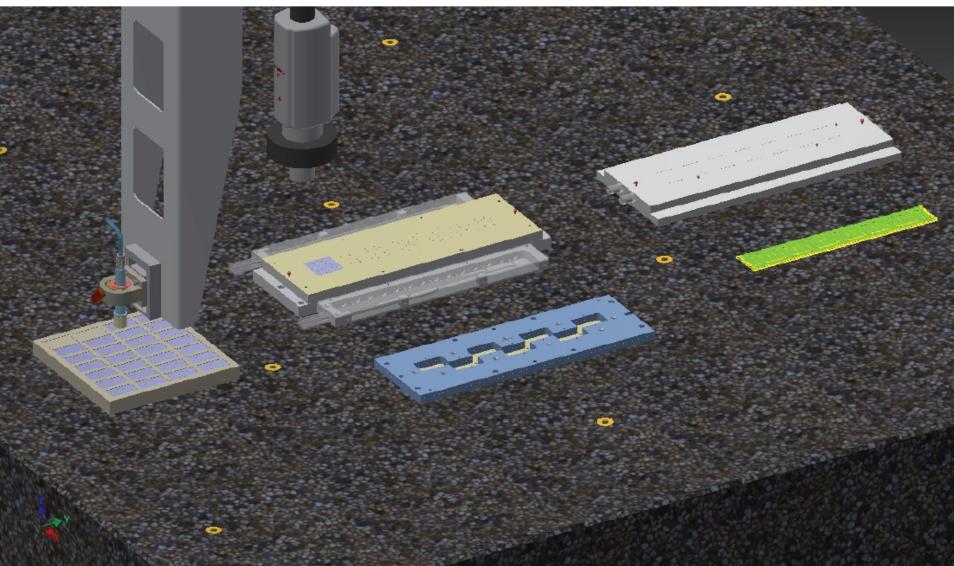
Deliveries are foreseen over 1.5 years from placement of the contract.

October 20

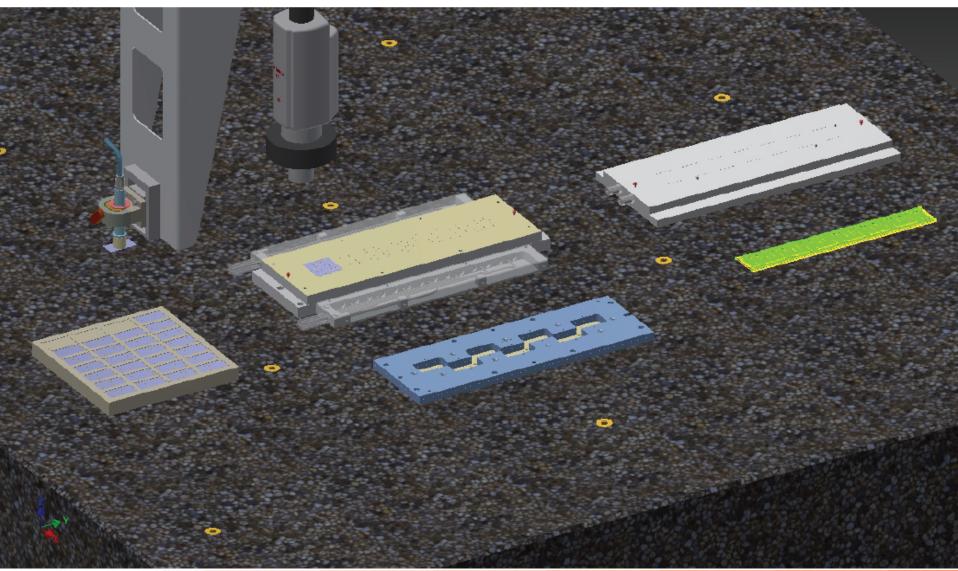




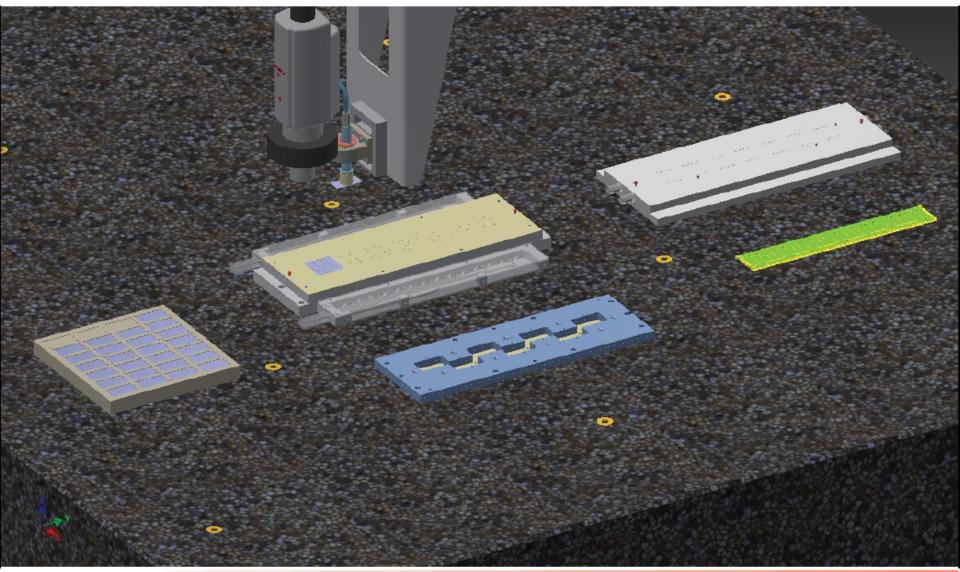




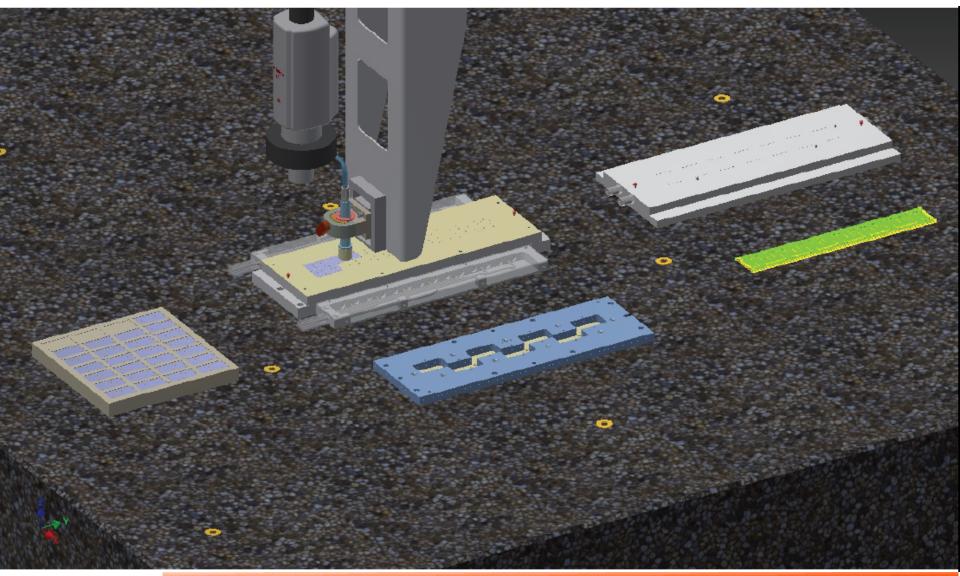




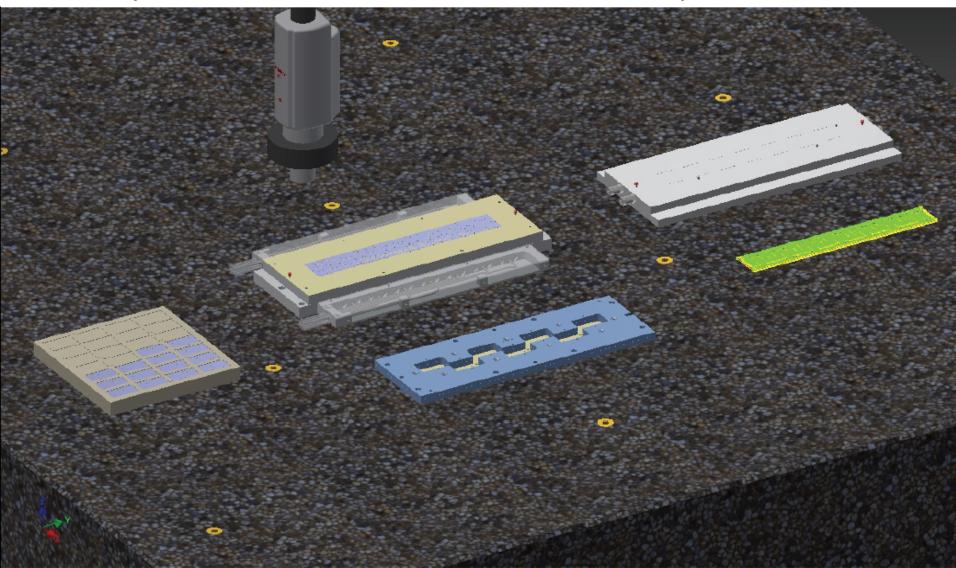




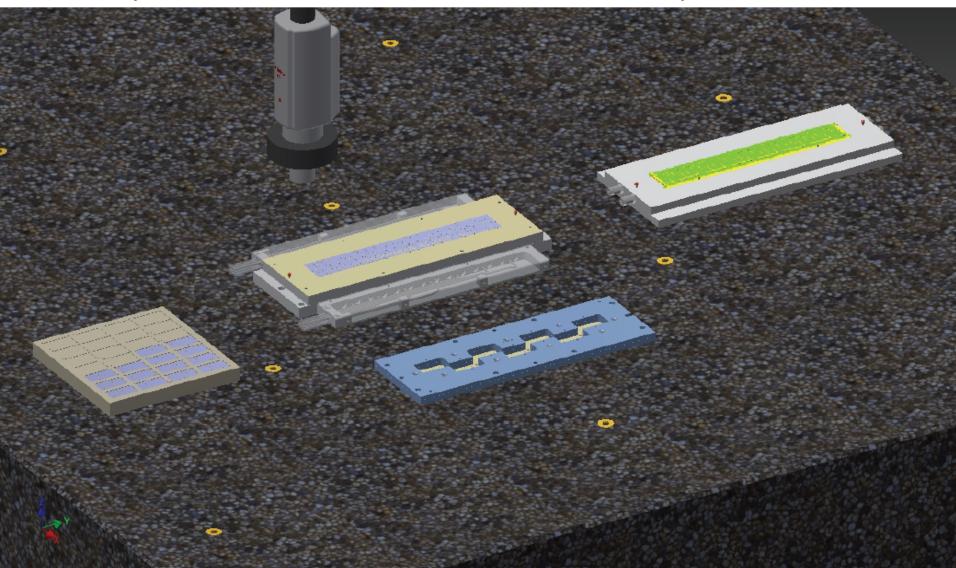




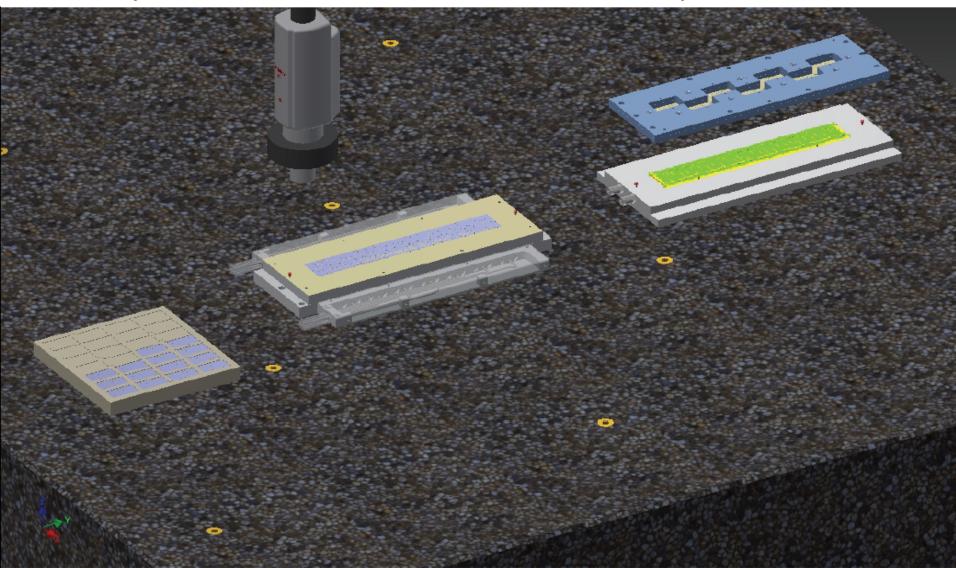




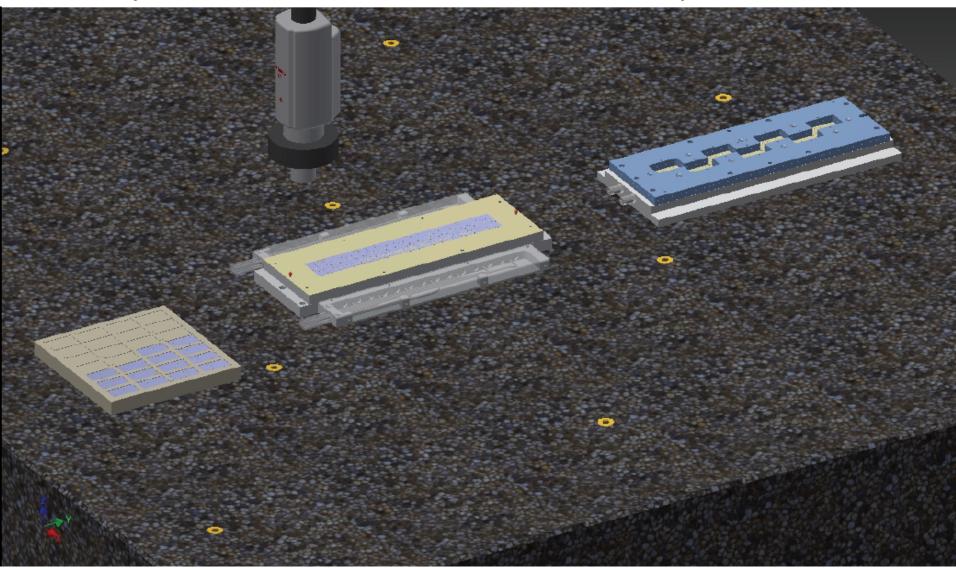




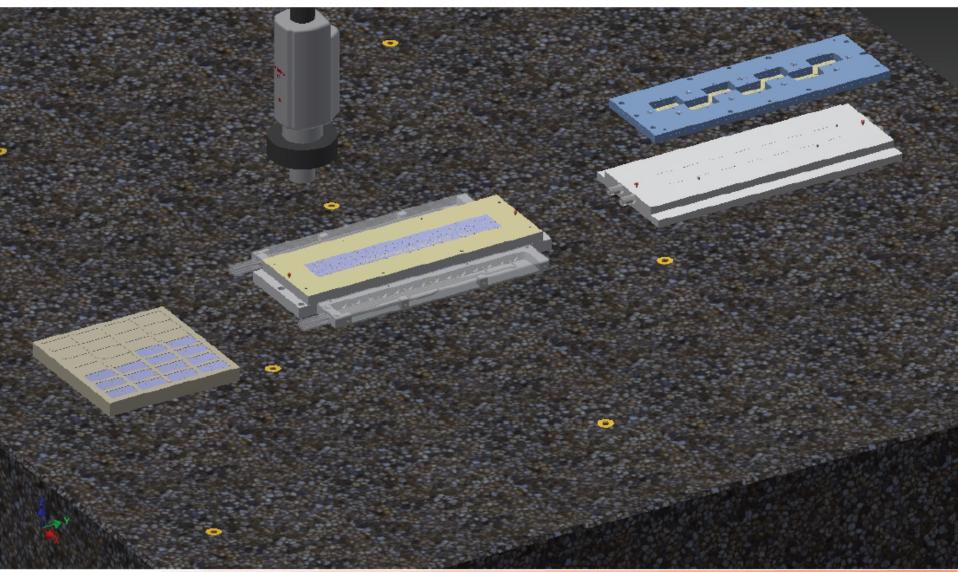




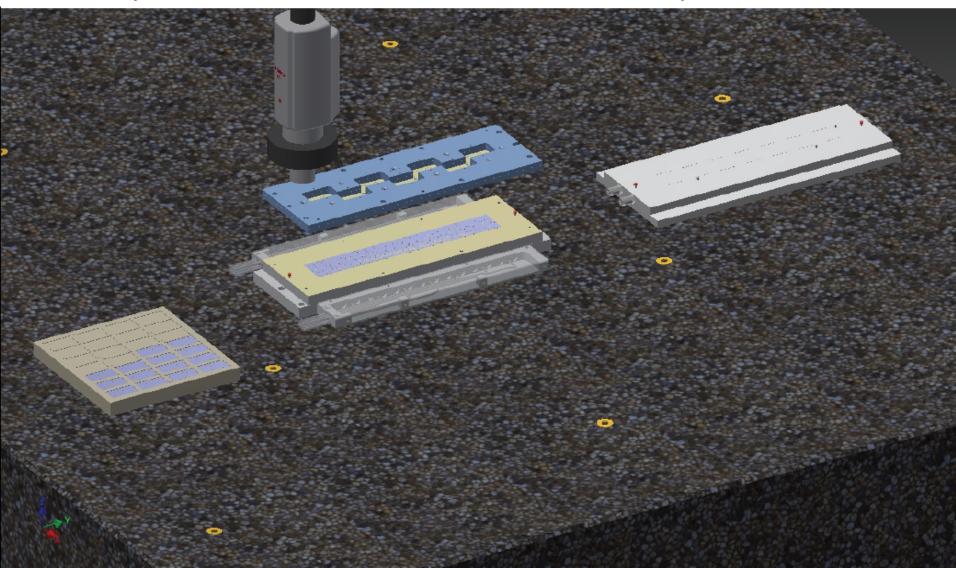




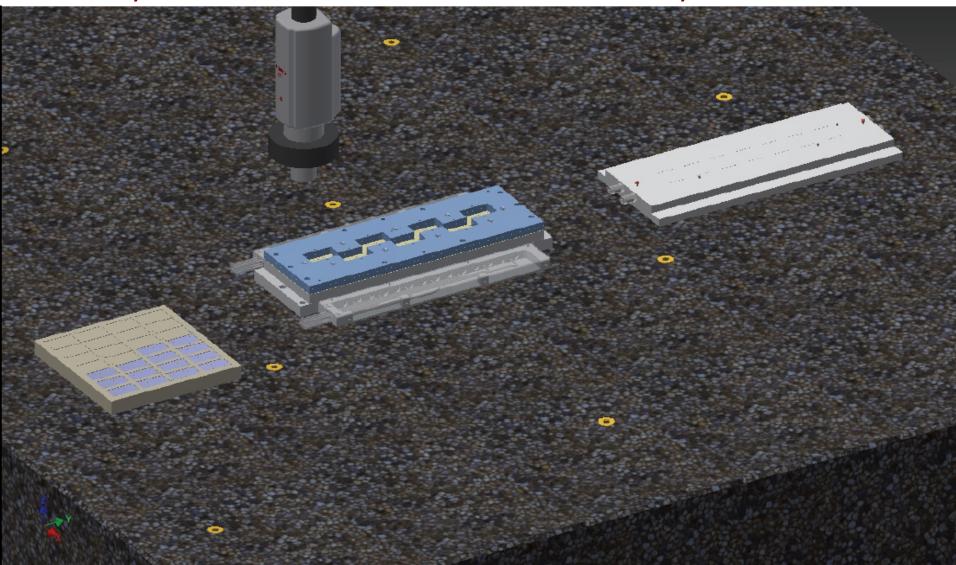




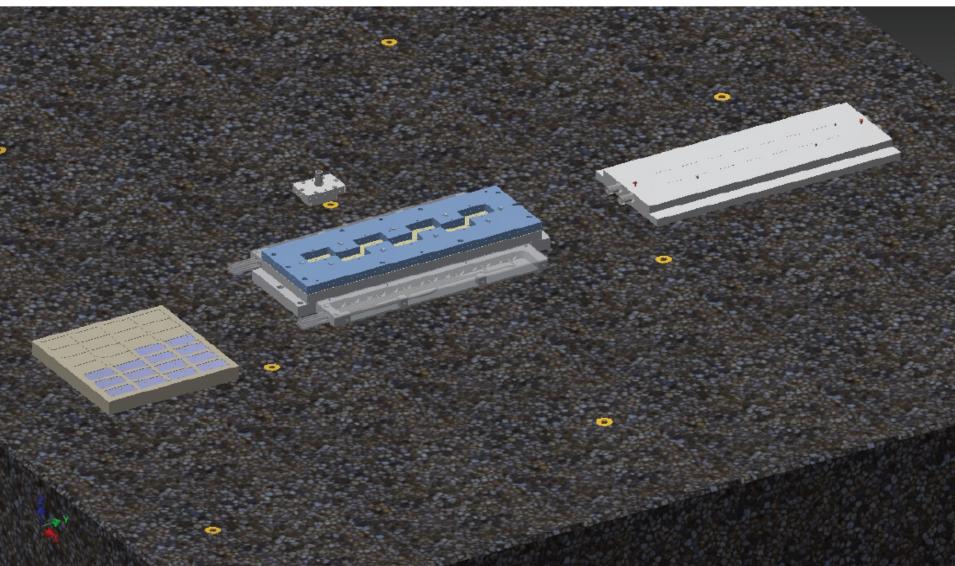




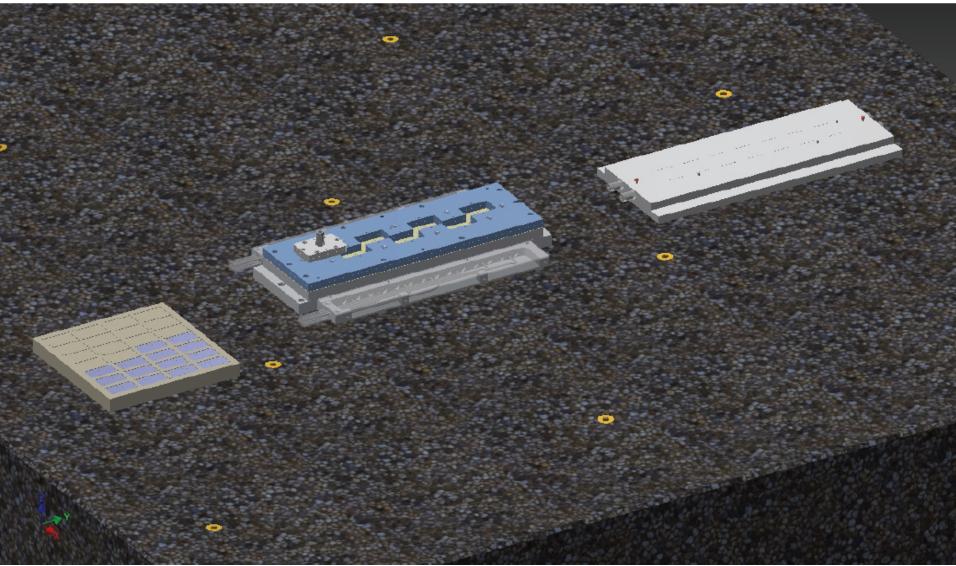




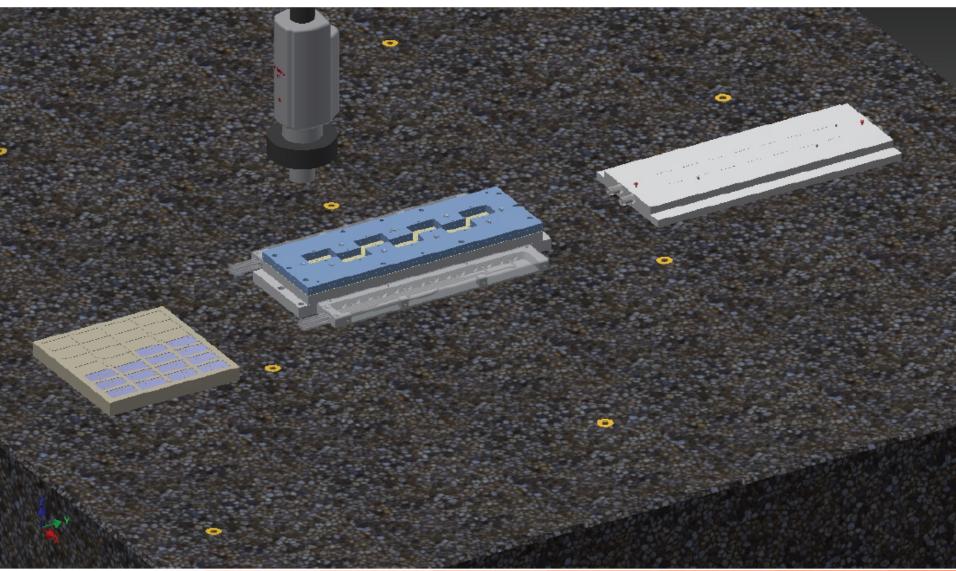




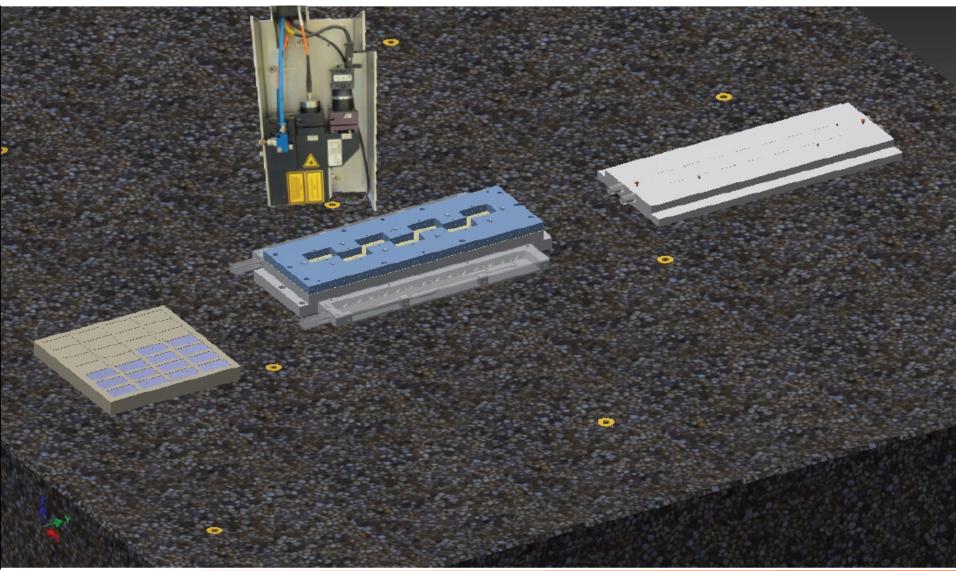




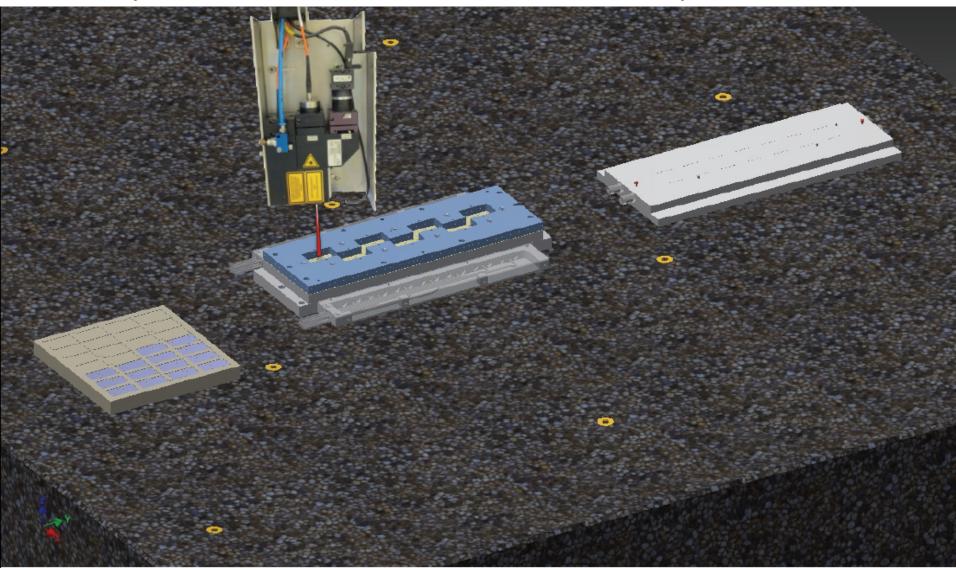






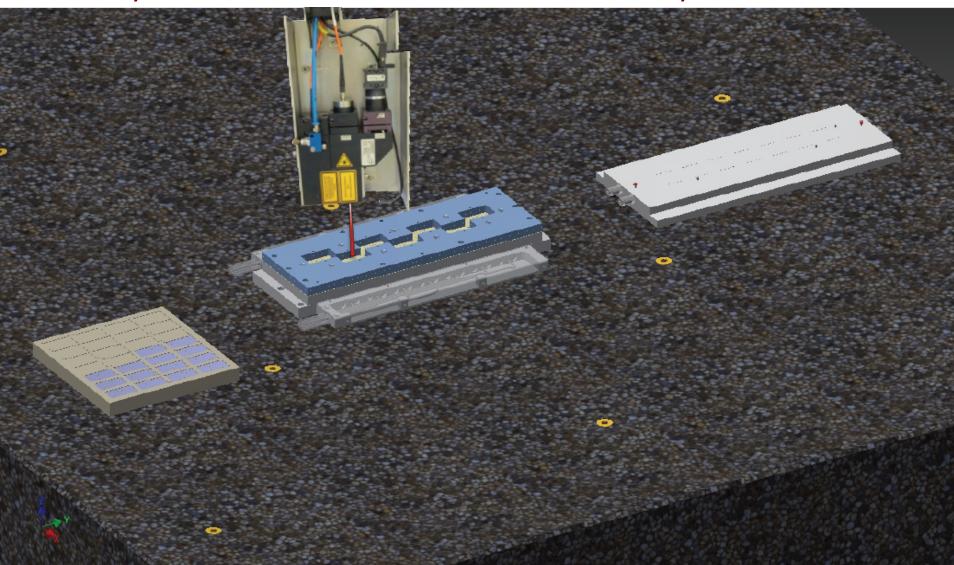








Assembly cartoon with automatic module assembly machine:





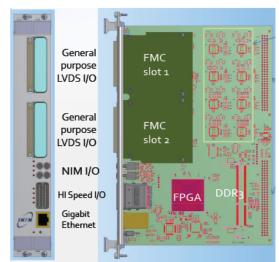
Module test and shipment:

1. Chips position - measurements of chips position in the module with respect to reference markers, which will remain visible throughout the following construction and integration operations

2. Module characterization - functional validation of modules according to a defined protocol

- Test System developed by Bari group
- **3. Module transport** shipment of qualified modules to the Stave Construction Centers
 - · Liverpool, LBNL, Turin and LNF, NIKHEF





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18/12/2014 36



Construction site preparation:

- ✓ ~40 m² of a clean room class 100000
- ☑ Compressed air and nitrogen supplies
- ☑ Automatic assembly system
- ☑ Optical microscope for visual inspection, equipped with with image acquisition system
- ☑ Test bench equipped with readout and control system, cooling system and power supply systems
- ☑ Radioactive sources (typically ⁹⁰Sr, activity ~10 MBq)
- ☑ Storage cabinets (antistatic, desiccator) for components and assembled modules

☑ ...



Timescale:

- Setting up of the infrastructures and training next year.
- Start module production mid 2016.

	2015				2016				2017			
	Q1	Q2	Q3	Q4	Q1	Q2	Q3	Q4	Q1	Q2	Q3	Q4
Laboratory setting up												
Automatic Assembly System: Procurement, Installation and Commissioning												
Training (@ CERN and Bari/Italy)												
Manual assembly and Laser soldering Automatic assembly system Test System												
Module Production												

Conclusion and Outlook



Transfer what we learned from the ALICE/ITS module assembly to PLAC/HFEE applications?



Several automatic options can be done by mean of vision system:

- Automatic chip visual inspection
- Fully automatic chip placement/alignment
- Automatic FPC placement/alignment?
- Automatic placement of soldering balls
- Quality control of soldering joints by vision system

Chip electrical test?

Conclusion and Outlook - We have a plan!







Thanks!

18/12/2014 41